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Art Unit

Examiner Name

STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Attorney Docket Number Sheet

				U. S. PATENT	DOCUMENTS	140
Examiner nitials*	Cite No.		Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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		FOREI	GN PATENT DOCU	MENTS		
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PTO/SB/08B (08-03)
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Sheet	1		of	1	Attorney Docket Number			

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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